



# Leica EM TXP

Target Surfacing System

Living up to Life

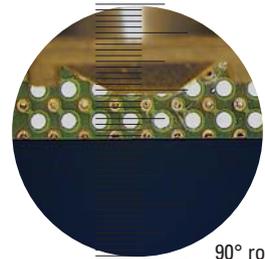
**Leica**  
MICROSYSTEMS

# Leica EM TXP – Target Surfacing

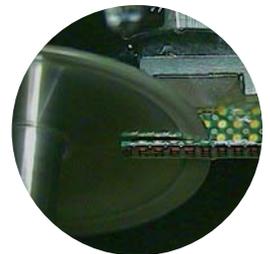
The Leica EM TXP is a unique target preparation device especially developed for cutting and polishing samples prior to examination by SEM, TEM and LM techniques. It excels with challenging specimens where pinpointing and preparing barely visible targets becomes easy. Before the Leica EM TXP, sawing, milling, grinding and polishing exactly to the target was often a very time-consuming and difficult procedure as points of interest were easily missed and specimens often difficult to handle due to their small size. With the Leica EM TXP such samples can easily be prepared. Furthermore, due to its versatility, the EM TXP is a very efficient tool for sample pre-preparation prior to ion beam milling and ultramicrotomy.



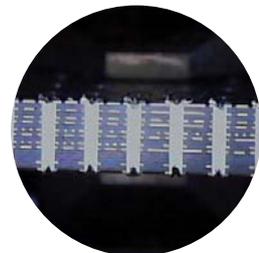
Leica Design by W. Hölbl



90° rotation view



Processing observation



Front face observation

# System

## Integrated Viewing System

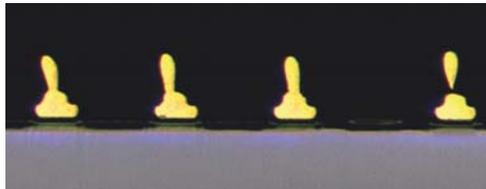
### **Stereomicroscopic target observation during the working process**

With the specimen pivot arm the sample can be observed during preparation at an angle between 0° and 60°, directly onto the front face, or 90° to the front face for distance determination with an eyepiece graticule. The Leica EM TXP features brilliant ring LED top light and optimized backlight illumination for excellent viewing.

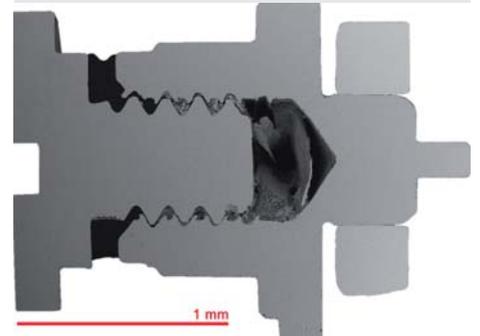
- **Accurate location and preparation of microtargets**
- ***In-situ* observation with a stereomicroscope**
- **Multifunctional machine processing**
- **Automatic process control to produce a mirror-like surface quality**
- **Brightness control and segment selection of LED-ring illumination**



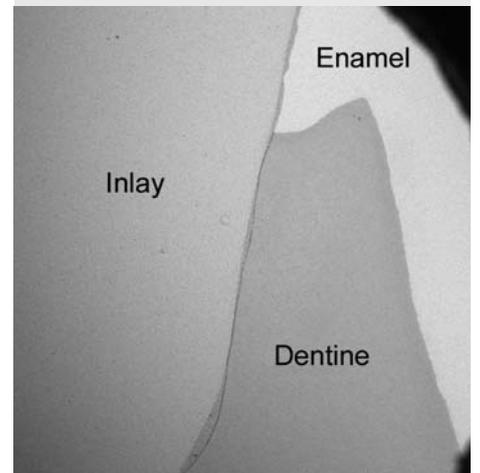
Viewing with full ring illumination



Viewing with quarter ring illumination



Cross section of watch assembly (processed without embedding)



Cross section of a tooth (processed without embedding)

# Process Possibilities

Once the sample is clamped into the specimen holder and inserted in the pivot arm, the specimen can be:

- milled
- sawn
- drilled
- ground
- and polished

without removing the sample from the Leica EM TXP and simply changing the tools while observing the process directly through the stereomicroscope. The tool and sample are enclosed within a protective chamber with a transparent cover for safety. This prevents access to moving parts and avoids particulate matter escaping. During milling a low-noise extraction and filtration unit with a Hepa filter (optional) provides a safe, dust-free environment.



Diamond and tungsten carbide millers



Diamond disc cutter



Lapping inserts 15, 9, 6, 3, 1, 0.5  $\mu\text{m}$

# Integrated Automatic Process Control

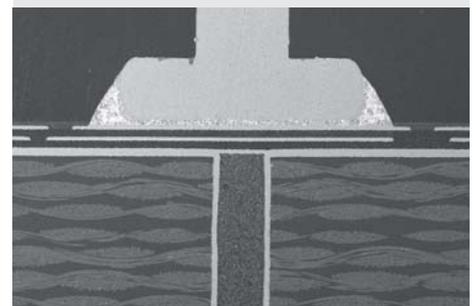
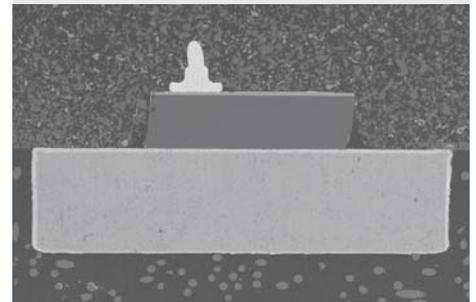
## Let the Leica EM TXP do the job

The Leica EM TXP automatic process control mechanism saves you from time-consuming routine sample preparation:

- with the automatic E-W guiding mechanism
- with the force-regulated feed control
- with the distance or time countdown function
- with force-controlled auto-advance for core-drilling and level sensor for the integrated lubricant cooling system



- **Pivot arm lever**
- **Hand wheel** for manual feed in steps of 0.5, 1, 10 and 100  $\mu\text{m}$
- **Control panel** for manual operation and setting of all parameters for automatic preparation

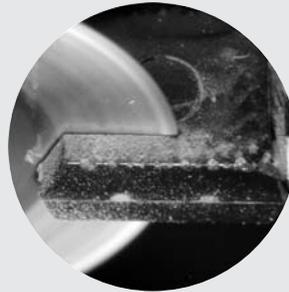


### Target preparation on surfaced sample for incident light LM and SEM

All processing steps are carried out consecutively on the Leica EM TXP without removing the sample for pinpointing the area of interest via another microscope or for making any adjustments. Preparing specimens observed during operation with the integrated stereomicroscope avoids the time consuming interruption of locating the target with a stand alone microscope and then re-aligning the sample in the polishing instrument.



Sawing



Observation via stereo microscope of the Leica EM TXP

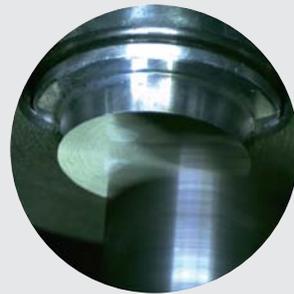
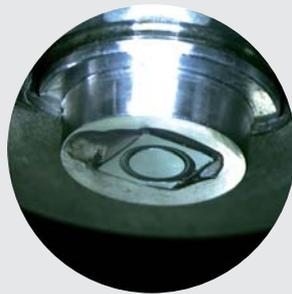


### Sample thinning for transmitted light LM or prior to ion thinning for TEM

Specimen thinning with the Leica EM TXP offers the advantage of observing the complete process during treatment and distance monitoring at each process step without the need to remove the sample for checking in another instrument.



After the sample is fixed onto the stub a 3 mm disc is cut out using the core-drill in conjunction with the force-regulated auto-advance. The first side is then finished using the grinding and polishing foils.



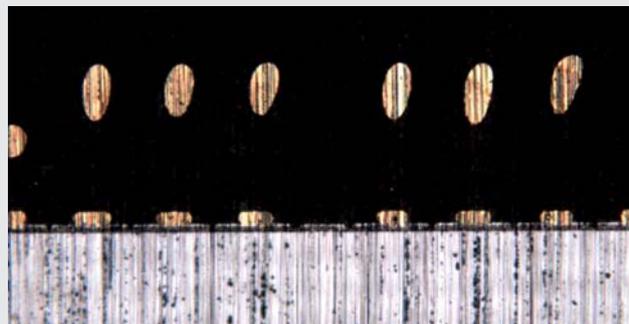
The surface of the stub is milled with the tungsten carbide miller so it is parallel to the grinding and the polishing plane for processing the second side of the sample.



**The Leica EM TXP is a unique target surfacing system developed for cutting and polishing samples.** Alignment of sample details can be rapidly performed using the alignment accessory. Thus, the EM TXP is the instrument of choice for pre-preparation of the sample prior to ion beam slope cutting with e.g. the Leica EM TIC020.



Sample holder attached on the alignment accessory. The micro-targets can be aligned during the process while observing with the stereo microscope.

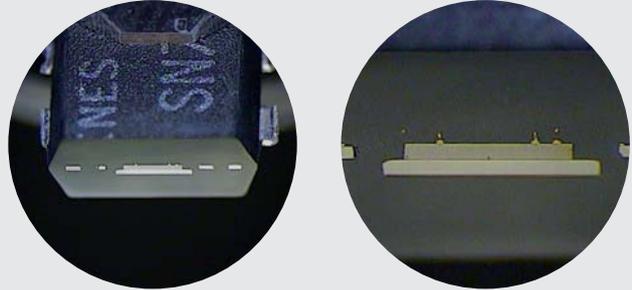


Within a few minutes all sample details are aligned. LM-image of gold wire bondings processed with the cut-off wheel and ground with 6  $\mu\text{m}$  diamond foil during alignment. The surface finish is good enough for subsequent finishing with the ion beam slope cutter, EM TIC020.





Grinding/polishing



The area of interest via the stereomicroscope of the Leica EM TXP



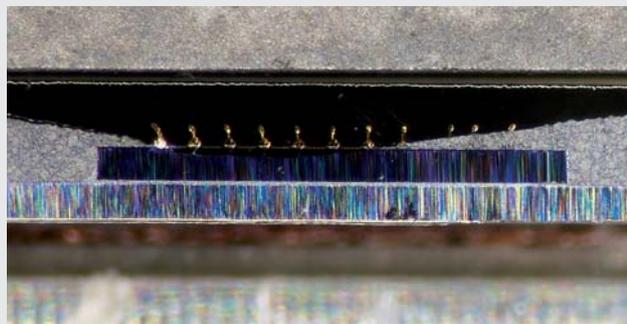
The prepared first side is fixed onto the surface of the stub. The second side is then cut, ground and polished. The thickness of the sample can be determined with the advance counter display.



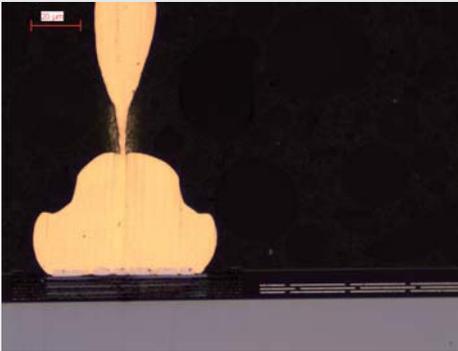
In such a manner, even hard and brittle materials can be thinned to be subsequently prepared for TEM investigation e.g. for ion thinning with the Leica EM RES101.



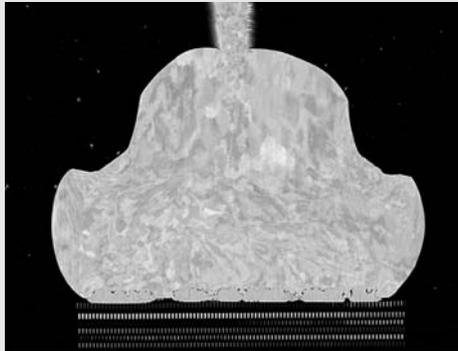
The Leica EM TIC020 features three ion guns in one assembly enabling > 4 mm cutting width and > 1 mm cutting depth.



Gold-wire bondings of IC-package during processing with the Leica EM TIC020. The dark area above the gold wires has already been polished by the ion beam.



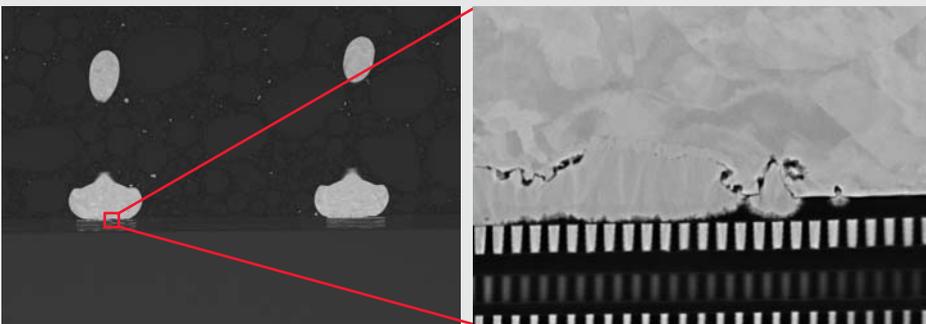
Gold-wire bonding of IC-package prepared with the Leica EM TXP (LM image).



Same gold wire bonding subsequently processed for half an hour with the Leica EM RES101 (SEM image).



Leica EM RES101 for ion beam processing of TEM and SEM samples.



High surface quality within a few hours. The user interaction time of the complete process is around 20 minutes using the Leica EM TXP prior to EM TIC020.

View the Details



# “With the user, for the user”

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